

## Investigation of open volume in photochromic $\text{YH}_x\text{O}_y$ thin films by positron annihilation lifetime spectroscopy

Ziying Wu<sup>1,\*</sup>, Tom de Krom<sup>1</sup>, Gijs van Hattem<sup>1</sup>, Giorgio Colombi<sup>2</sup>, Bernard Dam<sup>2</sup>, Henk Schut<sup>3</sup>, Marcel Dickmann<sup>4</sup>, Werner Egger<sup>4</sup>, Christoph Hugenschmidt<sup>5</sup> and Stephan W.H. Eijt<sup>1</sup>

<sup>1</sup>*Fundamental Aspects of Materials and Energy, Department of Radiation Science and Technology, Faculty of Applied Sciences, Delft University of Technology, Delft, The Netherlands*

<sup>2</sup>*Materials for Energy Conversion and Storage, Department of Chemical Engineering, Faculty of Applied Sciences, Delft University of Technology, Delft, The Netherlands*

<sup>3</sup>*Neutron and Positron Methods for Materials, Department of Chemical Engineering, Faculty of Applied Sciences, Delft University of Technology, Delft, The Netherlands*

<sup>4</sup>*Institut für Angewandte Physik und Messtechnik, Bundeswehr Universität München, Germany*

<sup>5</sup>*Physics Department and Heinz Maier-Leibnitz Zentrum (MLZ), TU München, Germany*

\*email: Z.Wu-2@tudelft.nl

$\text{YH}_x\text{O}_y$  thin films have attracted considerable interest due to the photochromic effect induced by UV illumination that was discovered in 2011 [1], leading to a large potential for their application in smart windows and sensors. However, only limited information on the microstructure of sputtered  $\text{YH}_x\text{O}_y$  thin films and its relationship to the photochromic effect is yet available. In this study, positron annihilation lifetime spectroscopy is used as a sensitive technique to study the size and concentration of open volume defects in  $\text{YH}_x\text{O}_y$ ,  $\text{YH}_2$ , Y and  $\text{Y}_2\text{O}_3$  thin films, deposited on fused silica substrates by magnetron sputtering. POSWIN is utilized to decompose the positron lifetime spectra. Three lifetime components are obtained for the metallic Y and  $\text{YH}_2$  thin films, while four lifetime components are necessary to accurately describe the lifetime spectra of the semiconducting  $\text{YH}_x\text{O}_y$  and insulating  $\text{Y}_2\text{O}_3$  thin films. A two-defect trapping model [2] is applied to extract the bulk lifetime and defect concentrations for all thin films. It is found that cation monovacancies are dominant in Y and  $\text{YH}_2$  thin films, at a concentration of the order of  $10^{-5}$  per Y atom. In the  $\text{YH}_x\text{O}_y$  and  $\text{Y}_2\text{O}_3$  thin films, larger vacancy clusters are present and the formation of positronium (Ps) in nanopores is observed. The porosity of  $\text{YH}_x\text{O}_y$  films increases with applied deposition pressure, that in turn leads to a higher oxidation degree of these films. Assuming the nanopores in the  $\text{YH}_x\text{O}_y$  films are spherical in shape, the Tao-Eldrup model [3, 4] applied to the Ps lifetime component  $\tau_4$  yields radii between 0.25 and 0.29 nm. This corresponds to vacancy clusters of around 7-10 missing atoms, i.e., of the size of around half a unit cell. Interestingly, vacancy clusters of similar size are indicated by the third lifetime component that we attribute to positron annihilation in such nanopores.

[1] T. Mongstad, C. Platzer-Bjorkman, J.P. Maehlen, L.P.A. Mooij, Y. Pivak, B. Dam, E.S. Marstein, B.C. Hauback, S.Z. Karazhanov, *Sol. Energy Mater. Sol. Cells* **95**, 3596 (2011).

[2] R. Krause-Rehberg and H.S. Leipner, *Positron Annihilation in Semiconductors - Defect Studies*, Springer-Verlag Berlin Heidelberg, 1999.

[3] M. Eldrup, D. Lightbody, J.N. Sherwood, *Chem. Phys.* **63**, 51 (1981).

[4] S.J. Tao, *J. Chem. Phys.* **56**, 5499 (1972).